

2815
LW/B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Koichiro TANAKA)
Serial No. 09/774,637) Group Art Unit: 2815
Filed: 02/01/01) Examiner: Jose Diaz
For: BEAM HOMOGENIZER, LASER)
IRRADIATION APPARATUS,)
SEMICONDUCTOR DEVICE, AND METHOD)
OF FABRICATING THE SEMICONDUCTOR)
DEVICE)

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
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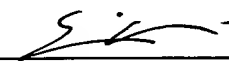
Timothy L. O'Brien

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed August 26, 2004.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed December 10, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of December 10, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,


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